NIR AND MIR ABSORPTION OF ULTRA-BLACK SILICON (UBS). APPLICATION TO HIGH EMISSIVITY, ALL-SILICON, LIGHT SOURCE

Sreyash Sarkar1, Ahmed A. Elsayed1,2, Elyes Nefzaoui1, Jérémie Dréville2, Philippe Basset1, Frédéric Marty1, Momen Anwar2, Yiting Yu4, Jiancun Zhao4, Xichen Yuan4, ZhongZhu Liang5, Diaa Khalil2,6, Yasser M. Sabry2,6, and Tarik Bourouina1,6

1Université Paris-Est, Laboratoire ESYCOM, ESIEE Paris, Noisy-le-Grand Cedex, France
2Electronics and Electrical Com. Depart., Faculty of Eng., Ain Shams University, Cairo, Egypt.
3Institut Pprime, CNRS, Université de Poitiers, ISAE-ENSMA, Futuroscope Chasseneuil, France
4Northwestern Polytechnical University, Xi’an, China
5State Key Laboratory of Applied Optics, Changchun Institute of Optics, Fine Mechanics and Physics, Chinese Academy of Sciences, Changchun, Jilin, China
6Si-Ware Systems, 3 Khalid Ibn Al-Waleed St., Heliopolis, Cairo, Egypt.

ABSTRACT

We present the Near-Infra-Red (NIR) and Mid-Infrared (MIR) absorption properties of Ultra-Black Silicon obtained by wafer-level cryogenic plasma processing. We found that when using highly-doped silicon, the spectral range of near-unity full absorption of light is extended from the visible range till a wavelength of 10 µm. This MIR wavelength range coincides with that of the maximum of black-body radiation from room temperature up to a few thousand Kelvin. Therefore, according to Kirchhoff’s Law, we take advantage of the enhanced properties of black silicon to realize ultra-compact light-sources of high efficiency, which are operated in combination with a MEMS-FTIR spectrometer.

INTRODUCTION

Black Silicon (BSi) has become nowadays, a well-established micro-nano-structured silicon surface that can be obtained by different techniques including cryogenic plasma [1] as considered in this work. BSi exhibits fascinating wetting and optical properties. In particular, due to its specific morphology, it is well-known for its excellent absorption of almost 100% of incident light [1-2], hence its name is Black according to its color to the naked eye. However, little is known about such optical properties, when considering other spectral ranges than the visible.

In this work, we started exploring the absorption properties of BSi in the infrared range, covering both the Near Infra-Red (NIR) and Mid-Infra-Red (MIR) spectral ranges from 1.5 µm until 10 µm wavelengths. Surprisingly excellent absorption, below 0.4% was found in this range – and even below 0.1% when considering the range from 1 to 8.5 µm. This behavior is exhibited especially when considering high-doping, leading to Ultra-Black Silicon (UBS) in the MIR. Then, in the second part of this paper, we took advantage of this remarkable property to explore the application of UBS to light-emitting devices based on black-body radiation.

RESULTS

1. Broadband Light Absorption of Ultra-Black Silicon extending to the Mid-Infra-Red

In our experiments, we considered two samples with low and high dopings respectively. BSi was produced by wafer-level cryogenic plasma [1-2]. Two additional flat samples with same doping levels were also taken as references. Figure 1 shows the spectral responses of those four samples, recorded in the infrared spectral range from 1.5 µm to 10 µm at room temperature. As a reminder, Figure 2 also recalls the typical responses recorded in the visible range; as most of the time, such a curve shows an increase of reflectance at the highest wavelengths, which also suggests that absorption should deteriorate if we increase the wavelength further. But surprisingly, this does not happen in our results shown in figure 1. On the contrary, one can see that reflectance is kept very low, below 1% up to 10 µm. For the highly doped silicon, reflectance remains even below 0.1% up to 7.5 µm and then starts increasing up to 0.4% at 10 µm. Such small numbers in this specific wavelength range are of paramount importance, especially when considering various applications.

Even though it was already known that high doping can lead to increased light absorption, especially when combined with Black Silicon [3-4], it is the first time evidence that this behavior extends to the Mid Infra-red is given. Moreover, it is also the first time that such low reflectivity levels, below 0.1 % are demonstrated. These rather surprising results led us to investigate the possible origins of this astonishing behavior, further.
2. Application to Broadband Light Source Based on Black-Body Emission

Indeed, the most relevant application relates to Black-body light-emitting devices. We have to recall first that according to the Kirchhoff's law of thermal radiation [5], emissivity is equal to absorptivity at a given wavelength and temperature, which means that any material that is excellent for light absorption will also be excellent for light emission.

Therefore, in the second part of this work, we introduce measurement results on such a high-performance light-emitting device based on black silicon [6-7]. Here, a resistive heating element is implemented based on a platinum resistor integrated onto the silicon surface (Figure 3). This enabled reaching temperature levels up to 800°C with voltage levels not exceeding 50 Volts.

Typical spectra obtained from such a device are illustrated in Figure 4. It is worth-mentioning that those spectra were recorded with a MEMS-FTIR spectrometer operating in the mid-infra-red range (Figure 5), suggesting that our UBS-based light source can be combined with such a spectrometer, for instance for chemical analysis, in an ultra-compact fashion, hence extending the application scope of UBS.

Figure 1: (a) Spectral reflectance in the Near- and Mid-infrared ranges comparing low-doping black silicon and high-doping black silicon, as well as two flat samples taken as a reference for both low doping and high doping. (b) Zoom on the two black silicon samples, illustrating the surprisingly very low reflectance levels below 0.1%.

Figure 2: Typical spectral response of (low-doping) black silicon, illustrating that the reflectance, even low, has a trend to increase in the upper visible range.

Figure 3: Photo of a platinum resistive heater integrated onto a black silicon surface, to produce a black-body radiation light-source.
CONCLUSIONS

In conclusion, we have explored the black silicon absorption properties in the mid-infra-red spectral range up to a wavelength of 10 μm. Using Highly Doped Silicon we obtained Ultra-Black Silicon with reflection levels below 0.1 % on an ultra-broadband spectral range extending from 1.5 μm to 8.5 μm. This exceptional behavior is not ascribed to the high level of doping of the nanostructured surface.

The exceptionally high absorptivity levels also translate into high emissivity of Ultra-Black Silicon. This was taken as advantage to demonstrate a high-efficiency broad-band light source based on black-body emission, operated by heating the ultra-black silicon by means of a platinum resistive element.

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CONTACT

Tarik BOUROUINA, tel: +33 1 4592 6692;
Tarik.bourouina@esiee.fr